

10/579051

AP2006-10951 PTO MAY 2006  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Terry L. Alford *et al.*  
Application Serial Number : To be assigned  
Date of Filing : May 9, 2006  
Title : *FLEXIBLE ELECTRONICS USING ION IMPLANTATION  
TO ADHERE POLYMER SUBSTRATE TO SINGLE  
CRYSTAL SILICON SUBSTRATE*  
Group Art Unit : To be assigned  
Examiner : To be assigned  
USPTO Customer No. : 26707  
Attorney Docket No. : 112624.00062

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INFORMATION DISCLOSURE STATEMENT  
PURSUANT TO 37 C.F.R. § 1.97

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U.S. Patent & Trademark Office  
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Applicant hereby brings to the attention of the Examiner the documents noted on the accompanying Form PTO-1449. This Information Disclosure Statement is being filed prior to the mailing date of a first Office Action.

It is respectfully requested that the information cited herein be expressly considered during the prosecution of this application and made of record on any patent to issue therefrom. Inclusion of a reference on the enclosed Form PTO-1449 is not to be construed as indicating the reference is prior art with respect to the subject application. Submission of this Information Disclosure Statement is not to be taken as evidence that a search has been conducted.

Terry L. Alford *et al.*  
Information Disclosure Statement

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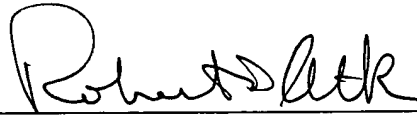
APR 20 2006 MAY 2006

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Respectfully submitted,  
**QUARLES & BRADY STREICH LANG, LLP**

May 9, 2006

By: \_\_\_\_\_



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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>		<b>Complete if Known</b>	
		Application Number	To be assigned <b>2005/9051</b>
		Filing Date	May 9, 2006
		First Named Inventor	Terry L. Alford
		Art Unit	To be assigned
		Examiner Name	To be assigned
Sheet 2 of 2	Attorney Docket Number	112624.00062	

OTHER PRIOR ART–NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	A	Hochbauer et al., "Physical mechanisms behind the ion-cut in hydrogen implanted silicon", J. Appl. Phys., 92(5):2335-2342, 2002	
	B	Hochbauer et al., "Investigation of the cut location in hydrogen implantation induced silicon surface layer exfoliation", J. Appl. Phys., 89(11):5980-5990, 2001	
	C	Hochbauer et al., "Hydrogen blister in boron and hydrogen coimplanted n-type silicon", Appl. Phys. Lett., 75(25):3938-3940, 1999	

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.  
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